



## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

Schueller et al.

Examiner:

Naff

Serial No.:

09/929,736

Group Art Unit:

1651

Filed:

August 14, 2001

For:

DEFORMABLE STAMP FOR PATTERNING THREE-DIMENSIONAL

SURFACES

**Assistant Commissioner for Patents** Washington, DC 20231

Sir:

8003 0 € MAL TECH CENTER 1600/290

## RESPONSE TO RESTRICTION REQUIREMENT

Filed herewith is a Petition for a one (1) month extension of time from December 22, 2002 up to and including January 22, 2003 to respond to the Office Action mailed November 22, 2002, in the above referenced case.

Responsive to the Office Action, Applicants elects Group I, claims 1-38, drawn to a method of patterning a surface, classified in class 435, subclass 174. This election is made without traverse.

Please charge any necessary fees or credit any overpayments to our Deposit Account No. 03-1721.

Respectfully submitted,

Charles Lyon, Ph.D.

Agent for Applicant

Limited Recognition Under 37 CFR §10.9(b)

CHOATE, HALL & STEWART **Exchange Place** 53 State Street Boston, MA 02109 (617) 248-5000

Dated: January 22, 2003

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Certificate of Mailing

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Linda M. Amato

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